







Biological Microscopes

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^{*1} NAMC (Nikon Advanced Modulation Contrast) is Nikon's unique modulation contrast observation method, which provides stereoscopic images similar to DIC observation, even with samples on plastic dishes.

*2 Emboss contrast is Nikon's unique contrast observation method. It provides pseudo-three-dimensional images using focal illumination, which gives high contrast to samples.

*3 Brighter than 100W

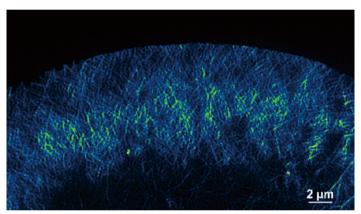
Super Resolution Microscopes

Super Resolution Microscope

N-SIM S

Achieving temporal resolution of up to 15 fps and twice the spatial resolution of conventional light microscopes enables fast super-resolution imaging of dynamic live cell events

- The unique high-speed structured illumination system enables high-speed super-resolution imaging at 15 fps* (*2D-SIM mode, 512 x 512 pixels, 2 msec exposure time)
- Utilization of "Structured Illumination Microscopy" technology achieves nearly twice (up to approx. 115 nm*) the resolution of conventional light microscopes (*excited with 488 nm laser, in 3D-SIM mode)
- Automated optimization of structured illumination patterns for different wavelengths and magnifications enables fast 2-color TIRF-SIM imaging
- The large imaging area of up to 66 square μm enables high throughput for applications/samples that benefit from larger FOV, such as a neurons
- The optional two-camera imaging adapter allows simultaneous two-wavelength super-resolution imaging with excitation of 488 nm and 561nm
- The personal super-resolution microscope N-SIM E, which provides a streamlined, affordable super-resolution system supporting only essential, commonly used excitation wavelengths and imaging modes, is also available



Growth cone of NG108 cell labeled with GFP-Lifeact for F-actin. Image courtesy of: Drs. Minami Tanaka and Kaoru Katoh, The National Institute of Advanced Industrial Science and Technology (AIST)



Super Resolution Microscope

N-STORM

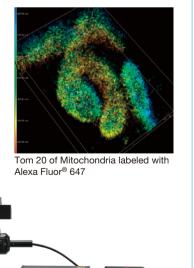
Resolution 10 times that of conventional light microscopes enables a greater understanding at the molecular level

 Ultra-high spatial resolution (up to 20 nm in xy) is achieved by utilizing accurate localization information of thousands of discrete fluorophore molecules within a specimen

• A tenfold enhancement has also been achieved in axial resolution (up to 50 nm)

 Multicolor super-resolution imaging utilizing both activator-reporter pairs and activator-free labels affords a critical insight into the localization and interaction of proteins at the molecular level

 The N-STORM 5.0, the newest version of N-STORM, is capable of more flexible imaging sequencing thanks to improved JOBS function



Inverted Microscopes

Inverted Research Microscopes

ECLIPSE Ti2-E/Ti2-A/Ti2-U

Leading platform for advanced imaging

- Bright and uniform illumination is provided across an unprecedented 25 mm field of view that maximizes the sensor area of large-format CMOS cameras, and significantly improves data throughput
- Ti2-E is a motorized and intelligent model for advanced imaging applications, and Ti2-A and Ti2-U are manual models with imaging capability for laser applications. Ti2-A has unique, intelligent features
- Ti2-E is compatible with real-time focus maintenance Perfect Focus System (PFS), auto correction collar, and external phase contrast system
- For its stable and drift-free platform, Ti2-E is perfect for super-resolution and confocal imaging
- The hardware-triggering capabilities of Ti2-E enhance even the most challenging, high-speed imaging applications
- Stability of PFS on Ti2-E is enhanced by reducing mechanical load on the nosepiece. It is compatible with broad wavelengths from ultraviolet to infrared, as well as various applications involving plastic dishes, single molecule and multi-photon imaging
- Ti2-E/Ti2-A's intelligent functions provide interactive guidance for microscope operation by integrating data from internal sensors, thus eliminating the possibility of user errors. The status of each sensor is automatically recorded during image acquisition
- The Water Immersion Dispenser automatically applies the appropriate amount of water to the tip of an objective, eliminating evaporation and overflow during experiments

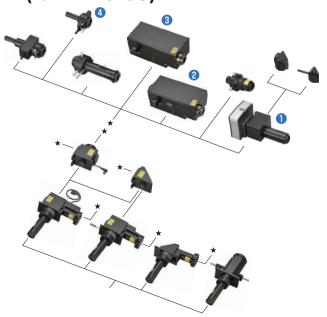


Illumination modules

Ti2-LAPP Modular Illumination System (for Ti2-E/A/U)

A wide range of illumination modules can be flexibly combined or added to create an imaging system tailored for individual research. Utilizing the Ti2's stratum structure, up to five modules can be simultaneously mounted and rapidly switched. Dual layer configuration of filter cube turrets enables optimal filter configuration for illumination modules on each layer.

- DMD Module: Allows for simultaneous multi-point photoactivation with customizable illumination ROIs
- N-STORM Module2: Equipped with motorized switching of illumination field for N-STORM microscopy
- 3 H-TIRF Module: Enables automatic laser focus adjustment and incident angle adjustment for TIRF observations
- ② EPI FL Module for Large FOV: Delivers a large 25 mm field of view and is perfect for epi-fluorescence imaging with cameras with large sensors



Inverted Microscopes

Inverted Research Microscopes

ECLIPSE Ts2R/Ts2R-FL

A compact inverted research microscope configurable with a wide variety of observation methods

- Space-saving compact body allows these models to be easily fit inside a laminar flow hood
- Low stage design helps reduce fatigue during repetitive sample exchange
- · Mechanical stage with long travel stroke enables observation of entire 96-well plates
- · High-intensity LED light source is used for both diascopic and epi-fluorescence illumination
- In addition to DIC and NAMC, the Emboss Contrast method is possible, enabling observation of thick samples with high contrast and relief images using standard condenser lenses and objectives, supporting both plastic and glass dishes
- The Ts2R-FL features built-in fluorescence light source and filter turret, accommodating up to four sets of LED units and filter cubes
- Illumination can be switched to epi-fluorescence with one button; the fluorescence illumination brightness adjuster is located on the same side of the microscope for intuitive operation (Ts2R-FL)
- Optional Contrast Shield blocks room light, making high S/N fluorescence observation possible even in brightly-lit rooms
- The spindle observation system allows accurate locating of spindle bodies, which is important for IVF, and also makes switching to NAMC and emboss contrast observation easy



ECLIPSE Ts2R (Diascopic illumination model)



ECLIPSE Ts2R-FL (Diascopic and epi-fluorescence illumination model)

Inverted Routine Microscopes

ECLIPSE Ts2/Ts2-FL

Fits in every laboratory — Simple to use and compact

- Space-saving compact bodies allow these models to be easily located next to incubators; camera port located on the side enables confirmation of what is on the stage from the observation position
- · Mechanical stage with long travel stroke enables observation of entire 96-well plates
- High-intensity LED light source is used for both diascopic and epi-fluorescence illumination
- The Emboss Contrast method allows observation of thick samples with high contrast and relief images using standard condenser lenses and objectives, supporting both plastic and glass dishes
- The Ts2-FL features built-in fluorescence light source and filter turret, accommodating up to three sets of LED units and filter
- Illumination can be switched to epi-fluorescence with one button; the fluorescence illumination brightness adjuster is located on the same side of the microscope for intuitive operation (Ts2-FL)
- Optional Contrast Shield blocks room light, making high S/N fluorescence observation possible even in brightly-lit rooms (Ts2-FL)



(Diascopic illumination model)



Accessories for Inverted Microscope

Micromanipulator System

NTX (for Ti2-E/A/U)

The NTX with compact and easy-to-assemble design ensures stable and smooth operation without needle drift. It provides microscopic and precise specimen micromanipulation in the fields such as ICSI (Intracytoplasmic Sperm Injection) and transgenic biotechnology.

(Manufactured by Narishige Co., Ltd.)



Epi-FI LED Illuminator

(for Ti2-E/A/U, Ni-E/U, FN1)

Equipped with an LED light, this epi-fluorescence illuminator requires zero warm-up time and ensures stable and quantitative brightness of illumination, thus is particularly suited to long periods of time-lapse imaging. It allows simultaneous lighting with multiple wavelengths and the intensity of each wavelength can be controlled. An LED has a minimum lifespan of 10,000 hours, eliminating the need for frequent lamp replacement.



HG Precentered Fiber Illuminator

Intensilight

(for Ti2-E/A/U, Ts2R-FL, Ni-E/U, Ci-E/L/S, FN1, AZ100/100M)

It comes equipped with a precentered, easy-to-replace mercury lamp that has a lifespan of up to 2,000 hours and is suitable for fluorescence observation. Motorized and manual models are both available.



Stage Top Incubator

STX series (for Ti2-E/A/U, Ts2R/Ts2R-FL)

It sustains the internal temperature at 37°C with humidity of 90% and CO₂ of 5% to keep the specimen in a stable and precise condition for over 1 week.

(Manufactured by Tokai Hit Co., Ltd.)



Thermal Plate Warmer

ThermoPlate TPi Series

(for Ti2-E/A/U, Ts2/Ts2-FL, Ts2R/Ts2R-FL)

Automatic thermocontrol system with a glass heating plate keeps the specimen at a set temperature. Temperature is adjustable from room temperature to 60°C in 0.1°C increments. (Manufactured by Tokai Hit Co., Ltd.)



Cell Incubator Observation

Cell Culture Observation System

BioStation CT

Automated stem cell screening in culture environment

- Operations from culture to observation of cells run automatically under optimal conditions in the same incubator
- Culture vessels are transferred from the rack to the microscope stage and cell image is captured according to a user-configured schedule
- Remote observation and setting from outside the laboratory via a network is possible
- Captures micro images from 2X to 40X with phase contrast observation using apodized phase contrast (APC) optics and fluorescence observation using threecolor LED illumination. A bird's eye macro view allows the entire vessel to be viewed from above
- High resolution whole vessel images can be acquired with Full Well Scan
 Observation. This mode allows automatic processing and stitching of images to
 reconstruct the entire image of the culture vessel, and quick and easy discovery of
 developing iPS colonies. Images are zoomed so that colonies can be seen without
 loss of resolution
- Optional image analysis software CL-Quant allows automatic cell detection from a phase contrast image, and enables identification and counting of iPS colonies



Time Lapse Imaging System

BioStation IM-Q

The perfect and simple solution for reliable time-lapse imaging

- A totally integrated cell incubation and time-lapse imaging system
- High-sensitivity cooled monochrome camera captures bright, high-contrast images
- Accurate, reliable data acquisition provided by precision XYZ control and by eliminating the focus drift caused by the stage movement and temperature change
- Powerful and intuitive software. Effortless operations with ergo controller and mouse
- Stable, consistent control of temperature, humidity and CO2 gas concentration maintains cell activity for long periods
- Exceptional phase contrast and fluorescence imaging quality
- · Instant set-up. Space-saving design. No need for darkroom
- · Convenient accessories include a vessel and chamber for multi-sample observation and built-in perfusion components



Upright Microscopes

Motorized Advanced Research Microscope

ECLIPSE Ni-E (focusing stage model and focusing nosepiece model)

Automated imaging capability for most advanced observations

- High-precision motorized focusing supports automated Z-series acquisition
- Observation method can be changed using buttons on the microscope body. Microscope settings are automatically set to optimal positions according to selected magnification
- · Various motorized accessories can be attached
- Stratum structure allows double layer mounting of a photoactivation unit and an epi-fluorescence attachment to enable simultaneous photoactivation and imaging
- High-speed motorized excitation/barrier filter wheel for multicolor imaging
- Exchangeable focusing mechanism from focusing stage to focusing nosepiece
- High optical performance: uniform and bright illumination using fly-eye optics
- Built-in, easy-to-reach image capture button. Angled operation buttons allow touch-type operations during observation



Ni-E (Focusing stage) configured with motorized epi-fluorescence illuminator, motorized condenser and motorized quadrocular tilting tube



Ni-E (Focusing nosepiece) configured with motorized stage, motorized epi-fluorescence illuminator, photoactivation unit, motorized quadrocular tilting tube and camera

Advanced Research Microscope

ECLIPSE Ni-U

Manual microscope with flexible selection of motorized options

- Motorized nosepiece, motorized epi-fluorescence cube turret and motorized shutter can be utilized
- Stratum structure allows double layer mounting of a back port unit and an epi-fluorescence attachment to enable simultaneous multichannel imaging with two cameras
- High optical performance: uniform and bright illumination using fly-eye optics
- Built-in, easy-to-reach image capture button



Ni-U configured with ergonomic binocular tube

Upright Microscopes

Clinical and Laboratory Microscopes

ECLIPSE Ci-E/Ci-L/Ci-S

Exceptional comfort for clinical and laboratory observation

- High-luminescent eco-friendly LED (Eco-illumination) for Ci-E/Ci-L and halogen illumination for Ci-S
- · Ci-E offers motorized magnification switching and automatic light intensity reproduction, enabling use of motorized condenser
- Angle and extension adjustable ergonomic binocular tube ensures observation with natural posture. Eye-point height can be lifted using an eyelevel riser
- Stage height can be lowered by adding a nosepiece spacer, and locked for easy refocusing. Height-adjustable stage handle. Durable, scratch-resistant ceramic-coated stage
- Built-in capture button allows easy imaging with the DS series camera



Ci-E configured with ergonomic binocular tube



Ci-L configured with ergonomic binocular tube and DS series camera



Ci-S configured with ergonomic binocular tube

Clinical & Educational Microscope

ECLIPSE E200

Outstanding cost performance—striking image sharpness, operability and durability

- Both high-luminescent LED (Eco-illumination) model and halogen lamp model are available
- Adopts CFI60 infinity optics for this class of microscope. Plan objectives that excel in image flatness come standard
- One-touch refocusing stage for easier specimen handling
- Focusing knob and stage handle are low-positioned and equidistant from operator, permitting onehanded operation in natural posture
- Ergonomic binocular tube and eye-level risers are available for adjusting the eyepoint
- · Anti-mold treated
- E200-F (model with field diaphragm) is also available
- Various accessories are available, such as dedicated epi-fluorescence attachment
- Halogen lamp model is compliant with 100V-240V (multi-voltage)
- The E200-dedicated epi-fluorescence attachment is equipped with an LED light source with a minimum lifespan of 10,000 hours



E200 (model without field diaphragm)

Upright Microscope

Educational Microscope

ECLIPSE E100

High optical quality, simple operation and rigid design

- High-luminescence LED (Eco-illumination) and halogen lamp models are both available
- CFI optical system and dedicated objectives for flat images
- Siedentopf-type eyepiece tube and eye level adjustments; digital camera attachable to trinocular eyepiece tube
- Adjustable condenser position (Simplified Kohler's Illumination System)
- Phase contrast observation for high-contrast viewing of transparent and colorless specimens
- Anti-mold treatment for objectives, eyepieces, and eyepiece tube



E100 configured with binocular tube

Polarizing Microscopes

ECLIPSE LV100N POL/Ci-POL/E200POL

- CFI60 optics deliver world-class optical performance
- Excellent basic performance, operability, durability and, above all, outstanding image sharpness
- LV100N POL is a research polarizing microscope that boasts twice the rigidity of conventional models and a brightness exceeding 100W (12V-50W model with centering quintuple nosepiece). The built-in Fly-Eye optics ensures uniform illumination, making it ideal for digital imaging
- ECLIPSE Ci-POL is compact yet offers high functionality, such as a nosepiece with DIN standard compensator slot (6V-30W model with centering quintuple nosepiece). Built-in capture button allows easy imaging with DS series cameras
- E200POL is a cost-efficient and extremely compact model (6V-30W multi-voltage model with quadruple nosepiece)



LV100N POL (diascopic illumination type)



Ci-POL (diascopic illumination type)



E200 POL (diascopic illumination type)

Microscope for Asbestos Identification

Polarizing/Dispersion Microscope

ECLIPSE LV100ND POL/DS

Dispersion staining microscopy that aids in the identification of asbestos

- Characteristic dispersion colors of each asbestos type corresponding to the refraction index of the immersion liquid can be observed using the phase contrast condenser and objectives (10X and 40X) for dispersion staining microscopy
- Qualitative asbestos analysis is possible by determination of birefringence and elongation (positive/negative); measurement of extinction angle, refractive index, and birefringence magnitude (retardation); observation of pleochroism



Fixed Stage Microscope for Electrophysiological Research

ECLIPSE FN1

Dedicated microscope for electrophysiological research with I-shaped body design—more room for smooth electrode manipulation

- The 40X and 60X objectives allow crisp high resolution IR-DIC imaging by correcting axial chromatic aberration up to near-IR light (850 nm)
- The 100X objective with 1.1 NA and 2.5 mm working distance comes with a correction function for depth- and thermally-induced aberrations
- The vertical motion nosepiece enables magnification changes without moving Petri dish (15 mm or less in height)
- Easy switching between IR light and reflected illumination
- \bullet With an optional variable magnification double port (0.35X, 2X, 4X), both wide field and high magnification observations can be carried out with a 16X objective alone
- Deep imaging of living specimens is possible in configuration with the A1 MP+/A1R MP+ multiphoton confocal system



All objectives have wide approach angles and long working distances (45° and 3.5 mm with 40X objective).



Configuration with Narishige micromanipulators and epi-fluorescence attachment

Stereo Microscopes

SMZ25/SMZ18

- Motorized zoom model SMZ25 is the first stereo microscope to offer a large 25:1 zoom ratio. Zoom ratio of manual zoom model SMZ18 is 18:1
- Optical path of both eyes boast high NA of up to 0.156 with the SHR Plan Apo 1X objective and SMZ25 zooming body
- Fly eye lens employed in the epi-fluorescence attachment ensures uniform brightness over the entire field of view even at the lowest magnifications
- Motorized focus and zoom operation (SMZ25)
- User-friendly remote control (SMZ25)
- Total magnification 3.15-315X (SMZ25), 3.75-270X (SMZ18), depending on objective used
- Compatible with various accessories including trinocular tubes



SMZ25 configured with motorized epi-fluorescence attachment and LED diascopec illumination base



SMZ18 configured with LED diascopic illumination stand

Accessories for SMZ25/SMZ18

LED Diascopic Illumination Base

The slim LED DIA Base is equipped with OCC illumination, which utilizes oblique lighting to enable high-contrast illumination of colorless and transparent specimens.

Fiber Diascopic Illumination Base

The Fiber DIA base features condenser lenses that can be switched between low and high magnifications. Furthermore, the OCC illumination system allows high-contrast illumination.

LED Ring Illumination Unit

LED Ring Illumination Unit is equipped with high-intensity, long-life (20,000 hours) LEDs. The illuminator's dial adjusts the intensity of the white LED.



LED Dark Field Unit

Darkfield observation is possible simply by attaching the darkfield unit to the base.



Simple Polarizing Attachment

The analyzer is attached to the objective and the polarizer to the base or stand to enable polarized observations.



Epi Fluorescence Attachment

A fly eye lens ensures bright high-contrast images over the entire field of view.

A motorized model with control via a remote control unit or imaging software is also available.





Stereo Microscopes

SMZ1270/1270i, SMZ800N

- SMZ1270/1270i provides highest-in-class zoom ratio of 12.7:1. Zoom ratio of SMZ800N is 8:1
- Total magnification 3.15-480X (SMZ1270/1270i), 5-480X (SMZ800N), depending on eyepieces and objectives used
- High-level chromatic aberration correction provides sharp images
- Automatic detection of zoom magnification in combination with the digital camera control unit. Objective information is also detected with the intelligent nosepiece. (SMZ1270i)
- Compatible with various accessories, including trinocular tubes, epi-fluorescence attachment and teaching head. The slim-type LED diascopic stand is equipped with OCC illumination. The nosepiece offers both a widened magnification range and on-axis imaging



SMZ1270 configured with binocular tube and LED diascopic illumination stand



SMZ1270i configured with trinocular tilting tube, intelligent nosepiece and LED diascopic illumination stand



SMZ800N configured with binocular tube and plain stand

SMZ745/SMZ745T

- Total magnification 3.35-300X
- Zoom ratio 7.5:1
- Compatible with a camera (SMZ745T)
- Eyepiece inclination 45°



SMZ745T configured with C-PS plain stand



SMZ745 configured with C-PS plain stand

SMZ445

- Total magnification 4-70X
- Zoom ratio 4.4:1
- Eyepiece inclination 45°



SMZ460

- Total magnification 3.5-60X
- Zoom ratio 4.3:1
- Eyepiece inclination 60°



Multi-purpose Zoom Microscope

Multizoom AZ100/AZ100M/AZ-C2+

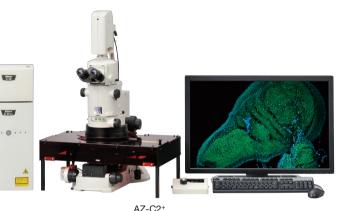
Continuously switchable magnifications, extending from macro to micro observation of the same specimen

- Covers a magnification range of 5X to 400X, thanks to 8X zooming optics and a unique triple nosepiece
- True on-axis observation and image capture are possible in the macro region
- · Comes standard with an aperture stop
- Tilting trinocular eyepiece tubes can accommodate a digital camera
- The dedicated stands combine two focuses, one with an 85-mm stroke on the column side and one with a 10-mm stroke on the front stage, enabling observation of tall samples
- AZ100M with motorized focusing and motorized zooming makes it easy to capture Extended Depth of Focus (EDF) images
- AZ-C2+ offers high-definition macro confocal image capture in a single shot. Deep imaging of in-vivo whole specimens is also possible





AZ100M configured with Epi-Fl attachment



Laser Units

LU-NV laser units

(for Ti2-E/A/U, Ni-E/U, FN1, AZ100)

Up to 8 wavelengths and 7 fiber outputs are available to choose from. Switching fiber output allows a single laser unit to simultaneously support multiple laser applications, such as TIRF and photoactivation modules, Confocal Microscope A1⁺ and C2⁺, and Super Resolution Microscope N-SIM and N-STORM.



LU-NV laser unit with LU controller box B (top)

LU-N4/N4S 4-laser unit, LU-N3 3-laser unit

(for Ti2-E/A/U, Ni-E/U, FN1, AZ100)

A compact and easy-to-use laser unit that can support laser application systems such as TIRF and photoactivation modules, Confocal Microscope A1⁺ and C2⁺. LU-N4/LU-N4S* is equipped with four lasers (405 nm, 488 nm, 561 nm, and 640 nm), while LU-N3 has three lasers (405 nm, 488 nm, and 561 nm).

*LU-N4S is compatible with spectral imaging but not with the Ti2-LAPP system.



LU-N4/N4S/N3 laser unit

Confocal Microscope Systems

Multiphoton Confocal Microscope

A1 MP+/A1R MP+

High-speed and high-resolution imaging of deep area in a living specimen

- \bullet The A1 MP+ is equipped with a galvano (non-resonant) scanner that enables high-resolution imaging of up to 4096 x 4096 pixels
- The A1R MP+ is equipped with both a galvano scanner and a resonant scanner. The resonant scanner allows both ultrafast imaging of up to 420 fps (at 512 x 32 pixels) and high-resolution imaging of up to 1024 x 1024 pixels (at 15 fps)
- Both models support simultaneous excitation imaging using a dual-wavelength IR laser
- Enables deep imaging with an ultrasensitive GaAsP (gallium arsenide phosphide) NDD
- Using 1300nm wavelength-compatible episcopic GaAsP NDDs enables deep imaging of up to 1.4 mm
- The multiphoton laser beam can be automatically aligned with a single click
- The A1-DUS spectral detector unit provides simultaneous acquisition of 32 channels. The A1-DUVB-2 GaAsP detector unit enables spectral imaging using a resonant scanner



A1+/A1R+

A1+ for high-resolution imaging, A1R+ for ultrafast and high-resolution imaging

- The A1⁺ is equipped with a galvano scanner that enables high-resolution imaging of up to 4096 x 4096 pixels, and high-speed imaging of 10 fps (at 512 x 512 pixels)
- The A1R⁺ is equipped with both a galvano scanner and a resonant scanner, allowing ultrafast imaging of up to 420 fps (at 512 x 32 pixels) as well as simultaneous photoactivation and imaging
- The high definition resonant scanner provides imaging of 1024 x 1024 pixels (at 15 fps) (with the A1R⁺)
- The high-sensitivity GaAsP multi detector unit enables much brighter imaging with less noise than conventional detectors
- The dichroic mirror with 30% increased fluorescence efficiency provides high image quality
- The A1-DUS spectral detector unit provides simultaneous acquisition of 32 channels, enabling fast spectral imaging at up to 512 x 32 pixels and 24 fps
- The A1-DUVB-2 GaAsP detector unit enables spectral imaging using a resonant scanner



Configured with Ti2-E

Confocal Microscope

C2+/C2si+

Powerful personal confocal microscope, essential for laboratories

- · Highly efficient scanning head and detector unit provide noiseless, high contrast images
- High-speed imaging of 8 fps (512 x 512 pixels) and 100 fps (512 x 32 pixels) is possible
- With a host of functions, such as image stitching (large images) and broad analytical capabilities
- 4-channel simultaneous acquisition, such as 3-channel confocal plus DIC
- Spectral detector for C2si⁺ acquires 32-channels of spectra with a single scan, enabling unmixing of overlapped spectra
- The C2-DUVB GaAsP detector unit allows spectral imaging with user-defined emission bandwidths





Configured with Ni-E

Cameras

Digital Cameras for Microscopes

Digital Sight Series

Cameras for capturing high quality microscopy images, including a high-resolution DS-Ri2 camera equipped with a large FX-format sensor, a DS-Qi2 monochrome camera with superior quantitative analysis capabilities, and a compact DS-Fi3 C-mount camera, are available.

F-mount CMOS cameras

Microscope Camera DS-Ri2



- Equipped with a 16.25-megapixel CMOS sensor for digital SLR cameras that has been optimized for microscopes
- Fast acquisition of high-resolution images up to 4908 x 3264 pixels
- Accurate color reproduction of microscopy images with Nikon's proprietary image processing engine
- High frame rate of up to 45 fps (1636 x 1088 pixels) enables fast focusing
- High-sensitivity low-noise color fluorescent imaging is possible

Monochrome Microscope Camera DS-Qi2



- Equipped with a large format 16.25-megapixel monochrome CMOS sensor
- High-sensitivity imaging of weak fluorescent signals
- Cooling mechanism allows low noise imaging with high S/N ratio
- Reliable quantitative analysis with excellent linearity
- High frame rate of up to 45 fps (1636 x 1088 pixels) enables fast focusing
- Time-lapse imaging with high temporal resolution

C-mount CMOS camera

Microscope Camera DS-Fi3



- Equipped with a high density 5.9 megapixel CMOS sensor
- Fast acquisition of high-resolution images up to 2880 x 2048 pixels
- High frame rate of up to 30 fps (1440 x 1024 pixels) enables fast focusing easy capturing of images in all types of observation methods
- Improved quantum efficiency and read noise provide fluorescence images with higher S/N ratios
- · Accurate color reproduction of microscopic images with Nikon's proprietary image processing engine
- · Can be directly connected to a PC via a fast USB3.0 interface

Camera control unit

Camera control unit DS-L4

- The DS-Fi3 can be set and operated by touch, or by connecting Bluetooth accessories such as a keyboard or mouse
- Large, 10.1 inch, 1920 x 1200 pixel touch-screen display
- Various digital interfaces, including a USB 3.0 connection
- Pre-programmed imaging modes for different observation methods
- · Allows control of motorized devices on ECLIPSE Ni-E/U and Ci-E



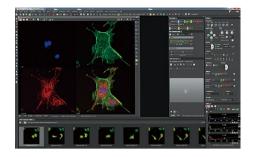
Configured with ECLIPSE Ni-U

Imaging Software

NIS-Elements

NIS-Elements is an integrated platform of imaging software developed by Nikon to achieve comprehensive control of microscope image capture and document data management.

NIS-Elements handles multidimensional imaging tasks flawlessly with support for capture, display, peripheral device control, and data management & analysis of images (up to six-dimensional images).



Nikon offers a number of microscope software packages to control and optimize the performance of its products.



NIS-Elements Advanced Research

NIS-Elements AR is optimized for advanced research applications. It features fully automated acquisition and device control through full 6D (X, Y, Z, Lambda (Wavelength), Time, Multipoint) image acquisition and analysis.



NIS-Elements Basic Research

NIS-Elements BR is suited for standard research applications. It features acquisition and device control through 4D (up to four dimensions can be selected from X, Y, Z, Lambda (Wavelength), Time, Multipoint) acquisition.



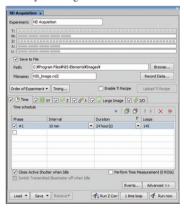
NIS-Elements Documentation

NIS-Elements D supports color documentation requirements in bioresearch, clinical and industrial applications, with basic measuring and reporting capabilities.

Various convenient plug-ins are available for advanced imaging and analysis capabilities.

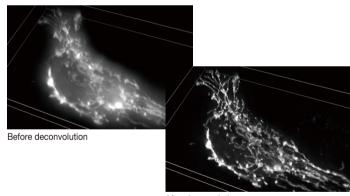
Multidimensional Capturing

Up to 6D image acquisition combining dimensions such as X, Y, Z, time, wavelength and multipoint is easily set using the intuitive GUI.



3D/2D Deconvolution

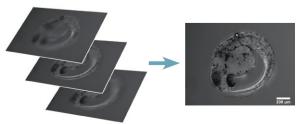
Haze and blur of the fluorescence image can be eliminated from the captured 3D image or from the 2D live preview image. (Separate plug-in for 3D and 2D)



After deconvolution

Extended Depth of Focus

With the Extended Depth of Focus (EDF) plug-in, images that have been captured in a different Z-axis using a motorized stage can be used to create an all-in-focus image. Also, it is possible to create stereovision images & 3D surface images to achieve virtual 3D imaging.



All-in-focus image created from a sequence of Z-stack images

Database

NIS-Elements has a powerful image database module that supports image and meta data. Various databases & tables can easily be created and

images can be saved to the database via one simple mouse-click. Filtering, sorting and multiple grouping are also available according to the database field given for each image.



Objectives

Type	Use	Model	Immersion	NA	W.D. (mm)	Cover glass thickness	Correction ring	Spring loaded	Brightfield	Darkfield	DIC	Phase contrast	Polarizing	Visible light	UV	Ti2-E PFS
		4X		0.10	30.00	_			0	^			Δ	0		
		LWD 20X		0.25	7.00 3.90	0.17			0	_			Δ	0		-
		40X		0.45	0.65	0.17		/	0	0			Δ	0		_
	Brightfield (CFI)	LWD 40XC		0.55	2.70-1.70	0-2.00	/	,	0	0			Δ	0		
		60X		0.80	0.30	0.17		1	0	•			Δ	0		
		100X Oil	Oil	1.25	0.23	0.17		/	0				\triangle	0		
		100XS Oil	Oil	0.50-1.25	0.23	0.17		/	0	0			Δ	0		
		P 4X		0.10	30.00	_			0				0	0		<u> </u>
	D 1 (OE)	P 10X	_	0.25	7.00	-			0	△ ○•			0	0		-
	Polarizing (CFI)	LWD P 20X P 40X		0.40	3.90 0.65	0.17		/	0	0			0	0		-
at		P 100X Oil	Oil	1.25	0.03	0.17		1	0				0	0		_
Achromat		DL 10X		0.25	7.00	-			0	Δ		© PH1	Δ	Δ		
Ach		LWD DL 20X		0.40	3.90	0.17			0	0		© PH1	Δ	Δ		
		LWD DL 20XF		0.40	3.10	1.20			0			© PH1	Δ	Δ		
	Phase contrast (CFI)	DL 40X		0.65	0.65	0.17		1	0	0		○ PH2	Δ	Δ		
		LWD DL 40XC		0.55	2.70-1.70	0-2.00	1		0	0		© PH2	Δ	Δ		
		DL 100X Oil	Oil	1.25	0.23	0.17		/	0			© PH3	Δ	Δ		<u> </u>
		BM 10X		0.25	7.00	0.70			0			© PH1 © PH1		Δ		-
		ADL 10XF	_	0.25	6.20	1.20			0			© PH1	Δ	Δ		+
	Apodized phase contrast (CFI)	LWD ADL 20XF LWD ADL 40XF		0.40 0.55	3.10 2.10	1.20			0			© PH1	Δ	Δ		+
	(4	LWD ADL 40XC		0.55	2.70-1.70	0-2.00	/		0	0		© PH2	Δ	Δ		+
		NAMC 10XF		0.25	6.20	1.20	,		0					Δ		+
	Advanced modulation	LWD NAMC 20XF		0.40	3.10	1.20			0					Δ		
	contrast (CFI)	LWD NAMC 40XC		0.55	2.70-1.70	0-2.00	1		0					Δ		
		1X		0.04	3.20	-			0				Δ	Δ		
		2X		0.06	7.50	_			0				Δ	Δ		
		4X		0.10	30.00	-			0				\triangle	0		
	Brightfield (CFI Plan)	10X		0.25	10.50	-			0	Δ			Δ	0		
		20X		0.40	1.20	0.17			0	0			Δ.	0		<u> </u>
		40X	0:1	0.65	0.56	0.17		/	0	0			Δ	0		-
		50X Oil 100X Oil	Oil	0.90 1.25	0.35/0.18	-/0.17 0.17		/	0	•			Δ	0		+
		DL 10X	Oil	0.25	10.50	-		/	0	Δ		© PH1	Δ	Δ		+
	Phase contrast	DL 20X		0.40	1.20	0.17			0	0		© PH1	Δ	Δ		+
		DL 40X		0.65	0.56	0.17		/	0	00		© PH2	Δ	Δ		$\overline{}$
		DL 100X Oil	Oil	1.25	0.20	0.17		/	0			© PH3	Δ	Δ		
nat	No cover glass	NCG 40X		0.65	0.48	0		1	0	0			Δ	0		
Plan Achromai	(CFI Plan)	NCG 100X		0.90	1.00	0		1	0	•			Δ	0		
n Ac	Dhara araturat	DL 10X		0.25	6.70	0.17			0			© PH1				
T Ø	Phase contrast (CFI BE Plan) For E100	DL 40X		0.65	0.60	0.17		1	0			© PH2				
		DL 100X Oil	Oil	1.25	0.14	0.17		/	0			© PH3				
		4X	_	0.10	25.00	-/0.17			0							+
	Brightfield	10X 20X		0.25	6.70 6.70	0.17			0							+
	(CFI BE Plan)	40X		0.25	0.60	0.17		/	0							-
	For E100	60X		0.80	0.00	0.17		/	0							+-
		100X Oil	Oil	1.25	0.14	0.17		/	0							+
		4X		0.10	30.00	0			0				Δ	0		
	Brighfield	10X		0.25	7.00	0			0	Δ			Δ	0		
	(CFI E Plan) For E200	40X		0.65	0.65	0.17		/	0	0			Δ	0		
		100X Oil	Oil	1.25	0.23	0.17		1	0				Δ	0		
	IMSI (CFI Plan)	LWD IMSI 100XC		0.85	1.30-0.95	0.60-1.30	1		0	•	0		0	0		
	Brightfield (CFI S Plan	ELWD 20XC		0.45	8.20-6.90	0-2.00	/		0	0	0		0	0	0	•
	Fluor)	ELWD 40XC	_	0.60	3.60-2.80	0-2.00	1		0	0	0		0	0	0	•
Plan Fluor		ELWD 60XC ELWD ADM 20XC		0.70	2.60-1.80	0.10-1.30	/		0	0	- 0	© PH1	U	0	0	•
an	Apodized phase contrast	ELWD ADM 20XC		0.45	8.20-6.90 3.60-2.80	0-2.00 0-2.00	1		0	0		© PH1		0	0	•
0	(CFI S Plan Fluor)	ELWD ADL 60XC		0.70	2.60-1.80	0.10-1.30	/		0	0		© PH2		0	0	_
	Advanced modulation contrast	ELWD NAMC 20XC		0.45	8.20-6.90	0-2.00	/		0			<u> </u>		0	0	$\overline{}$
	(CFI S Plan Fluor)	ELWD NAMC 40XC		0.60	3.60-2.80	0-2.00	/		0					0	0	
		4X		0.20	15.50	-			0				Δ	0	◎ 340	•
Б		10X		0.50	1.20	0.17		/	0	0	0		Δ	0	◎ 340	•
2	Brightfield	20X		0.75	1.00	0.17		1	0	0	0		Δ	0	◎ 340	•
Super Filor	(CFI Super Fluor)	40XC		0.90	0.34-0.26	0.11-0.23	1	1	0	•	0		Δ	0	◎ 340	
S		40X Oil	Oil	1.30	0.22	0.17		√w/stopper	0		0	EXT PH3-40X	Δ.	0	◎ 340	•
		100XS Oil	Oil	0.50-1.30	0.20	0.17		/	0	0		1	△	0	◎ 340	₩
FILLO		P 5X	-	0.15	23.50	0		-	0	_			0	0	0	+
Universal Plan Fluor	No cover glass polarizing	P 10X		0.30	17.50	0			0	0			0	0	0	+
SS	(TU Plan Fluor EPI)	P 20X P 50X		0.45	4.50 1.00	0		,	0	U			0	0	0	+
ক	1	II. JUV	1	U.0U	1.00	0		1	0			1	0	0	0	

Note 1. Model name
The below letters, when included in the model names, indicate the respective features.
F: for use with 1.2mm-thick cover glass
C: with correction ring compatible with Auto Correction Collar
NCG: for use without cover glass
S: with correction ring compatible with Auto Correction Collar
NCG: for use without cover glass
S: with iris
WI: water immersion type
W: water dipping type
M: multi immersion (oil, water, glycerin) type
IMSI: for IMSI
DS: compatible with dispersion staining microscopy

Note 2. Cover glass thickness

— : can be used without cover glass
0: use without cover glass

Note 3. Darkfield microscopy
Possible with the following

\(\times \) universal condenser (dry) and darkfield ring
\(\times \) : above and darkfield condenser (dry)

\(\times \) : darkfield condenser (oil)

Note 4. Phase rings are classified by objective NA PHL, PH1, PH2, PH3: condenser cassette modules. EXT PH3, EXT PH4: external phase contrast modules for Ti2-E.

Note 5. Fluorescence microscopy (UV)

Δ: possible with visible light that has a longer wavelength than the excitation light used for DAPI

3: suitable

9: recommended for best results

340: high transmittance with an ultraviolet wavelength range of up to 340 nm

ıype	Use	Model	Immersion	NA	W.D. (mm)	Cover glass thickness	Correction ring	Spring loaded	Brightfield	Darkfield	DIC	Phase contrast	Polarizing	Fluore Visible light	scence UV	NIR	T
		4X		0.13	17.20	-			0				Δ	0	0		Г
		10X		0.30	16.00	0.17			0	Δ	0		0	0	0		Т
		20X		0.50	2.10	0.17			0	00	0		0	0	0		Т
					0.51-0.35												t
		20XC MI	Oil, water, glycerin	0.75	0.51-0.34	0-0.17	1	1	0	0	0		0	0	0		
	Brightfield	4014			0.49-0.33					0	_						╀
	(CFI Plan Fluor)	40X		0.75	0.66	0.17		√	0	00			0	0	0		Ļ
		40X Oil	Oil	1.30	0.24	0.17		√w/stopper	0		0	EXT PH3-40X	0	0	0		Ļ
		60XC		0.85	0.40-0.31	0.11-0.23	1	1	0	•	0		0	0	0		L
		60XS Oil	Oil	0.50-1.25	0.22	0.17		1	0	0	0	EXT PH3-60X	0	0	0		
		100X Oil	Oil	1.30	0.16	0.17		√w/stopper	0		0		0	0	0		Т
		100XS Oil	Oil	0.50-1.30	0.16	0.17		1	0	00	0		0	0	0		T
1		DL 4XF		0.13	16.50	1.20			0			○ PHL		0	0		t
		DLL 10X		0.30	16.00	0.17			0	Δ		© PH1		Ō	Ō		t
		DL 10XF		0.30	15.20	1.20			0	Δ		© PH1		0	0		t
				0.50					0	0		_		0	0		╀
	Phase contrast	DLL 20X		_	2.10	0.17					_	© PH1					╀
	(CFI Plan Fluor)	DLL 40X		0.75	0.66	0.17		1	0	00		© PH2		0	0		\downarrow
		DLL 100X Oil	Oil	1.30	0.16	0.17		√w/stopper	0			© PH3		0	0		L
		DM 40X		0.75	0.66	0.17		1	0	0		© PH2		0	0		
		BM 40X		0.75	0.66	0.17		1	0	0		© PH2		0	0		Г
Ì	Apodized phase contrast	ADH 100X Oil	Oil	1.30	0.16	0.17		√w/stopper	0			© PH3		0	0		T
-	(CFI Plan Fluor)	Lambda 2X		0.10	8.50	_			0				0	0	Δ	0	t
1		Lambda 4X		0.20	20.00	_			0				0	0	Δ	0	†
1						ļ		,	0	Δ			0	0	Δ	0	+
ı		Lambda 10X		0.45	4.00	0.17		✓					_			-	+
J		Lambda 20X		0.75	1.00	0.17		1	0	00	0		0	0	Δ	0	1
J		VC 20X		0.75	1.00	0.17		1	0	0	0		0	0	0		
ı		Lambda 40XC		0.95	0.25-0.16	0.11-0.23	1	1	0	•	0		0	0	\triangle	0	
	Brightfield	Lambda 60XC		0.95	0.21-0.11	0.11-0.23	/	1	0	•	0		0	0	Δ	0	T
ı	(CFI Plan Apo)	Lambda 60X Oil	Oil	1.40	0.13	0.17		1	0		0	EXT PH3-60X	0	0	Δ	0	t
ı		VC 60XC WI	Water	1.20	0.31-0.28	0.15-0.18	1	/	0		0	EXT PH3-60X	0	0	0	Ť	t
ı						+			0					0		0	t
ı		IR 60XC WI	Water	1.27	0.18-0.16	0.15-0.19	1	1	U			EXT PH3-60x	0	U	Δ	0	Ŧ
Flan Apochromat		Lambda 100X Oil	Oil	1.45	0.13	0.17		1	0		0	EXT PH3-100X EXT PH4-100X	0	0	Δ	0	
		VC 100X Oil	Oil	1.40	0.13	0.17		1	0		0	EXT PH3-100x	0	0	Δ		I
ı		NCG 100X Oil	Oil	1.40	0.16	0		1	0		0		0	0			Ť
ı		DM Lambda 20X		0.75	1.00	0.17		/	0	0		© PH2		0	Δ	0	t
ı		DM Lambda 40XC		0.95	0.25-0.16	0.11-0.23	/	/	0	•		© PH2		0	Δ	0	t
ı	Phase contrast			0.95			_		0					0	Δ		t
ı	(CFI Plan Apo)	DM Lambda 60XC			0.21-0.11	0.11-0.23	1	/		_		○ PH2					+
ı		DM Lambda 60X Oil	Oil	1.40	0.13	0.17		1	0	•		© PH3		0	Δ	U	1
Į		DM Lambda 100X Oil	Oil	1.45	0.13	0.17		1	0			© PH3		0	Δ	0	
	0 11: (05:100.01 4.)	IR 60XC WI	Water	1.27	0.18-0.16	0.15-0.19	/	1	0		0	EXT PH3-60X	0	0	0	0	ı
ı	Super-resolution (CFI SR Plan Apo)	IR 60XAC WI	Water	1.27	0.18-0.16	0.15-0.19	1		0		0	EXT PH3-60X	0	0	0	0	t
Ì	Super-resolution (CFI HP Plan Apo)	VC 100X Oil	Oil	1.40	0.13	0.17	-	/	0		0	EXT PH3-100X	0	0	Δ		t
ł		VO 100X OII	OII	1.40				•			Ť	EXTTIO 100X					t
ı	Super-resolution (CFI SR HP Plan Apo)	Lambda S 100XC Sil	Silicone Oil	1.35	0.31-0.29 (23°C) 0.30-0.28 (37°C)	0.15-0.19 (23-37°C)	1		0		0		0	0	0		
1		LWD Lambda S 20XC WI	Water	0.95	0.99-0.90	0.11-0.23	1		0	•	0		0	0		0	1
		Lambda S 40XC WI	Water	1.25	0.20-0.16	0.15-0.19	/	/	0		0	EXT PH3-40X	0	0	0		t
J	Confocal (CFI Apo)	LWD Lambda S 40XC WI	Water	1.15	0.61-0.59	0.15-0.19	/		0	•	0	EXT PH3-40X	0	0	0		1
J							-		0	_			0	0	0		+
J		Lambda S 60X Oil	Oil	1.40	0.14	0.17		1			V	EXT PH3-60X			⊌		1
		TIRF 60XC Oil	Oil	1.49		0.13-0.19 (23°C) 0.15-0.21(37°C)	1		0		0	EXT PH4-60X	0	0	\triangle		
	Evanescent (CFI Apo)					0.15-0.21(37 C) 0.13-0.19 (23°C)			_		_		_	_			+
I		TIRF 100XC Oil	Oil	1.49	0.15-0.09 (37°C)	0.13-0.19 (23 C) 0.14-0.20(37°C)	1		0		0	EXT PH4-100X	0	0			
ĺ	Super-resolution (CFI SR Apo)	TIRF 100XAC Oil	Oil	1.49	0.16-0.10 (23°C)	0.13-0.19 (23°C)	/		0		0	EXT PH4-100X	0	0	Δ		İ
I	Super-resolution (CFI HP Apo)	TIRF 100XAC Oil	Oil	1.49	0.16-0.10 (23°C)	0.14-0.20 (37°C) 0.13-0.19 (23°C)	/		0		0	EXT PH4-100X	0	0	Δ		1
					0.16-0.10 (23°C)	0.14-0.20 (37°C) 0.13-0.19 (23°C)			0		_		0	0	Δ		1
	Super-resolution (CFI SR HP Apo)	TIRF 100XC Oil	Oil	1.49	0.15-0.09 (37°C)	0.14-0.20(37°C)	1		0		0	EXT PH4-100X			Δ		
	Use: Clearing	Model	Immersion	NA	W.D. (mm)	Cover glass thickness	Correction ring	Spring loaded	Brightfield	Darkfield	DIC	Phase contrast	Polarizing	Fluore Visible light	scence	NIR	
lt	iphoton Confocal (CFI Plan Apo)	10XC Glyc	Water, Oil, Glycerin	0.50	Upright: 5.50 Inverted: 2.00	0-0.17	√ *1		0	0				0		0	
lt	iphoton (CFI 90)	20XC Glyc *3	Glycerin	1.00	8.20	-	√ *2		△*4							0	1
	Use: Asbestos	Model	Immersion	NA	W.D. (mm)	Cover glass thickness	Correction ring	Spring loaded	Brightfield	Darkfield	DIC	Phase contrast	Polarizing	Fluore Visible light	scence	NIR	I
r	persion Staining (CFI)	R-DS 10X		0.25	7.00	0.17						© PH1					1
÷								-				U r⊓i	-				+
÷	persion Staining (CFI Plan)	C-DS 10X		0.25	13.00	0.17										-	1
ŗ	persion Staining (CFI Plan Fluor)	R-DS 40X		0.75	0.66	0.17		✓				◎ PH2					1
	Use: Water dipping	Model	Immersion	NA	W.D.	Cover glass	Correction	Spring loaded	Brightfield	Darkfield	חור	Phase	Polarizing	Fluoresc		N	
		Minne	IIIIIICISIUII	IVA	(mm)	thickness	ring	opining roaded	2giittibid	- minoid	5.0	contrast		Visible light	UV	infra	ır
					()											_	ø

Has Makes Produce	Model	Income and the		W.D.	Cover glass	Correction	Spring loaded	Drightfield	Dorlefield	DIC	Phase	Polarizing	Fluoresce	ence	Near-
Use: Water dipping	Model	Immersion	NA	(mm)	thickness	ring	Spring loaded	Dilgillielu	Darkileiu	DIC	contrast		Visible light	UV	infrared DIC
Multiphoton Confocal (CFI75 Apo)	25XC W *3	Water	1.10	2.00	0	1		0	•	0		0	0	0	0
Multipriotori Cornocai (CF175 Apo)	25XC W 1300 *3	Water	1.10	2.00	0	1		0	•	0		0	0	0	0
DIC (CFI Plan Fluor)	10X W	Water	0.30	3.50	0			0		0		0	0	0	0
ID DIO (OEL A)	NIR 40X W	Water	0.80	3.50	0			0	•	0		0	0	\triangle	0
IR-DIC (CFI Apo)	NIR 60X W	Water	1.00	2.80	0			0	•	0		0	0		0
DIC (CFI Plan)	100XC W	Water	1.10	2.50	0	1		0	•	0		0	0		0
DIC (CFI75)	LWD 16X W *3	Water	0.80	3.00	0			0	•	0		0	0	0	0

Note 6.
Brightfield/DIC/Fluorescence (visible light) microscopy

\(\triangle : \text{possible but not recommended} \)
\(\triangle : \text{suitable} \)
\(\triangle : \text{recommended for best results} \)

Note 7. Polarizing

\(\triangle \) possible but not recommended

\(\triangle \) suitable

\(\triangle \) retardation measurement is possible with a polarizing microscope

Note 8. Ti2-E PFS

compatible with PFS

- *1 With correction for refractive index of immersion medium (1.33-1.51)
 *2 With correction for refractive index of immersion medium (1.44-1.50)
 *3 Dedicated for FN1 and Ni-E focusing nosepiece type
 *4 Correction wavelength range: from 587 nm, can be used as a finder

Combinations of DIC Prisms and Objectives For Ti2 and Ts2R*1 series inverted microscopes

				LWD Con	denser Lens			CLW	D Condenser	Lens, HNA Dr	y Lens		HNA Oil Lens			
		Star	ndard	High (Contrast	High R	esolution	Sta	ndard	High R	esolution	Sta	ndard	High R	esolution	
		Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slide	Condenser Module	DIC Slider	Condenser Module	DIC Slider	
10X	Super Fluor 10X Plan Apo Lambda 10X	LWD N1 Dry	10X	_	_			-	_			-	_			
	S Plan Fluor ELWD 20XC	LWD N1 Dry	20XC II]												
20X	Super Fluor 20X Plan Fluor 20X Plan Fluor 20XC MI Plan Apo Lambda 20X Plan Apo VC 20X	LWD N2 Dry	20X	LWD N1 Dry	20X-C			HNA N2 Dry	20X			HNA N2 Oil	20X			
	Apo LWD Lambda S 20XC WI		60X II-R]			60X II-R				60X II-R			
	S Plan Fluor ELWD 40XC	LWD N1 Dry	40XC]	_			-	_			-	_]		
40X	Super Fluor 40XC Plan Fluor 40X Plan Apo Lambda 40XC Apo LWD Lambda S 40XC WI	LWD N2 Dry	40X I	LWD N1 Dry	40X I-C			HNA N2 Dry	40X I			HNA N2 Oil	40X I			
	Plan Fluor 40X Oil Super Fluor 40X Oil Apo Lambda S 40XC WI	- ыу	40X II					DIY	40X II			Oil	40X II			
	S Plan Fluor ELWD 60XC	LWD N1 Dry	60XC					-	_]		-	_			
	Plan Apo Lambda 60XC Apo TIRF 60XC Oil		60X I				60X I-R		60X I		60X I-R		60X I		60X I-R	
60X	Plan Fluor 60XC Plan Fluor 60XS Oil Plan Apo Lambda 60X Oil Apo Lambda S 60X Oil	LWD N2 Dry	60X II			LWD NR Dry	60X II-R	HNA N2 Dry	60X II	HNA NR Dry	60X II-R	HNA N2 Oil	60X II	HNA NR Oil	60X II-R	
	Plan Apo VC 60XC WI Plan Apo IR 60XC WI SR Plan Apo IR 60XC WI SR Plan Apo IR 60XAC WI		60X IV	_	_		60X IV-R		60X IV		60X IV-R		60X IV		60X IV-R	
100X	Plan Apo Lambda 100X Oil Plan Apo VC 100X Oil HP Plan Apo VC 100X Oil SR HP Plan Apo Lambda S 100XC Sil Apo TIRF 100XC Oil SR HP Apo TIRF 100XAC Oil SR HP Apo TIRF 100XC Oil	LWD N2 Dry	100X I			LWD NR Dry	100X I-R	HNA N2 Dry	100X I	HNA NR Dry	100X I-R	HNA N2 Oil	100X I	HNA NR Oil	100X I-R	
	Plan Fluor 100X Oil Plan Fluor 100XS Oil		100X II				100X II-R		100X II		100X II-R		100X II		100X II-R	
	Plan LWD IMSI 100XC	IMSI N2 Dry	100X III			_		_		_	_	_		_	_	
	Plan Apo VC 100X Oil*2		100X I	IMSI N2 Dry	100X I-R											

^{*1} Compatible with the LWD condenser lens only. Contact Nikon for information about compatible objectives. *2 When used for IMSI

For Ni-E (focusing stage)/Ni-U upright microscopes

			Universal C	ondenser Dry/Moto	orized Universal Co	ndenser Dry			DIC Cond	lenser Oil		
		Stan	idard	High C	ontrast	High Re	solution	Star	ndard	High Re	solution	
		Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	
10X	Super Fluor 10X Plan Fluor 10X Plan Apo Lambda 10X	N1 Dry	10X	-	_			-	_			
	S Plan Fluor ELWD 20XC	N1 Dry	20XC II									
20X	Super Fluor 20X Plan Fluor 20X Plan Fluor 20XC MI Plan Apo Lambda 20X Plan Apo VC 20X	N2 Dry	20X	N1 Dry	20X-C	-	_	N2 Oil	20X	-	_	
	S Plan Fluor ELWD 40XC	N1 Dry	40XC	-	_			-	_			
40X	Super Fluor 40XC Plan Fluor 40X Plan Apo Lambda 40XC	N2 Dry	40X I	N1 Dry	40X I-C			N2 Oil	40X I			
	Super Fluor 40X Oil Plan Fluor 40X Oil		40X II						40X II			
	S Plan Fluor ELWD 60XC	N1 Dry	60XC					-	_			
	Plan Apo Lambda 60XC Apo TIRF 60XC Oil		60X I				60X I-R		60X I		60X I-R	
60X	Plan Fluor 60XS Oil Plan Fluor 60XC Plan Apo Lambda 60X Oil Apo Lambda S 60X Oil	N2 Dry	60X II	-	_	NR Dry	60X II-R	N2 Oil	60X II	NR Oil	60X II-R	
	Plan Apo VC 60XC WI		60X IV]			60X IV-R	-	_	-		
100X	Plan Apo Lambda 100X Oil Plan Apo VC 100X Oil Plan Apo NCG 100X Oil Apo TIRF 100XC Oil	N2 Dry	100X I			NR Dry	100X I-R	N2 Oil	100X I	NR Oil	100X I-R	
	Plan Fluor 100X Oil Plan Fluor 100XS Oil		100X II			100X II-R			100X II		100X II-R	

For Ni-E (focusing nosepiece)/FN1 fixed stage microscopes

		FN-C LWD Condenser					
		Condenser Module	DIC Slider				
10X	Plan Fluor 10X W	N1 Dry	10X				
16X	LWD 16XW (CFI75)		16X I				
25X	Apo 25XC W Apo 25XC W 1300	N2 Dry	25X I				

		FN-C LWD Condenser						
		Condenser Module	DIC Slider					
40X	Apo NIR 40X W		40X III					
60X	Apo NIR 60X W	N2 Dry	60X I					
100X	Plan 100XC W		100X III					

Epi-fluorescence Filter Cubes

Filter Cubes for Ni-E/U, Ci-E/L/S, Ti2-E/A/U, Ts2R-FL*1 AZ100/100M

Excitation	Filter Cubes	Wavelengths	Characteristics
	UV-1A	EX 365/10 DM 400 BA 390	Narrow band pass—only 365 nm (i line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching
UV	UV-2A	EX 355/50 DM 400 BA 410	•Standard filter cube for UV
	DAPI	EX 375/28 DM 415 BA 460/60	For DAPI, cutting off FITC (green) and TRITC (red) Soft-coated type for high signal/noise Band-pass Barrier Filter used to cut off green and red
V	V-2A	EX 400/40 DM 430 BA 440	•Standard filter cube for V
BV	BV-2A	EX 420/40 DM 455 BA 460	Standard filter cube for BV
	B-2A	EX 470/40 DM 505 BA 510	Standard filter cube for B For FITC + Counter-stain (TRITC, PI)
В	FITC	EX 480/30 DM 505 BA 535/45	Soft coated type for high signal/noise For FITC (green), cutting off Rhodamine red Band-pass Barrier Filter used to cut off red
	GFP-B	EX 470/40 DM 500 BA 535/50	Bandpass filter cube for GFP
	G-2A	EX 535/50 DM 575 BA 580	•Standard filter cube for G
G	TRITC	EX 540/25 DM 565 BA 605/55	For TRITC (Rhodamine) Soft coated type for high signal/noise Band-pass Barrier Filter used to cut off reds above 643 nm
	Texas Red	EX 560/40 DM 595 BA 630/60	For Texas Red® Soft coated type for high signal/noise Band-pass Barrier Filter used to cut off reds above 660 nm

^{*1} Only when the Ts2R-FL is used in combination with the HG Precentered Fiber Illuminator Intensilight.

High Quality Filter Cubes for Fluorescent Protein/Fluorophore

The HQ series causes minimal image shifts when superimposing multi-color images by adopting high-dimension accuracy glass. 32 mm diameter filter cubes for large FOV imaging are also available for the Ti2 series inverted microscope.

Filter Cubes	Wavelengths
DAPI-U HQ	EX 395/25, DM 425, BA 460/50
CFP HQ	EX 436/20, DM 455, BA 480/40
GFP HQ	EX 470/40, DM 495, BA 525/50
FITC HQ	EX 480/40, DM 510, BA 535/50
YFP HQ	EX 500/20, DM 515, BA 535/30
Cy3 HQ	EX 535/40, DM 565, BA 590/40
mCherry HQ	EX 570/40, DM 600, BA 645/75
Cy5 HQ	EX 620/60, DM 660, BA 700/75

Multi-Band Filter Cubes

Filter Cubes	Applications
Dual	DAPI/FITC
	CFP/YFP
Duai	GFP/DsRed
	FITC/Texas Red
Triple	DAPI/FITC/TRITC
Triple	DAPI/FITC/Texas Red

Filter Cubes for Ts2-FL/Ts2R-FL/E200 (LED illumination)

Filter Cubes	Wavelengths
C-LED385	EX 390/38, DM 420, BA 475/90
C-LED455*2	EX 448/23, DM 465, BA 472
C-LED470	EX 470/40, DM 500, BA 534/55
C-LED505*2	EX 496/29, DM 518, BA 543/37
C-LED525	EX 525/50, DM 560, BA 597/58
C-LED560*2	EX 550/50, DM 600, BA 630/75
C-LED590*2	EX 561/75, DM 610, BA 652/65
C-LED625	EX 621/58, DM 660, BA 706/73

^{*2} Incompatible with E200

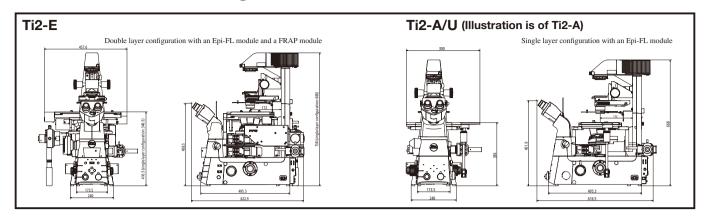
Filter Cubes for SMZ25/18

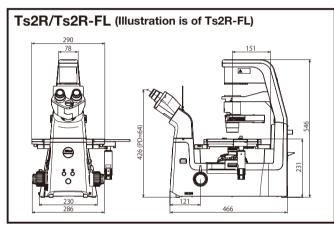
Filters	Wavelengths
DAPI	EX395/25, DM425, BA460/50
CFP	EX436/20, DM455, BA480/40
GFP-B	EX460-500, DM505, BA510-560
GFP-L	EX460-500, DM505, BA510
YFP	EX500/20, DM515, BA535/30
RFP	EX530-560, DM570, BA590
mCherry	EX560/40, DM585, BA630/75

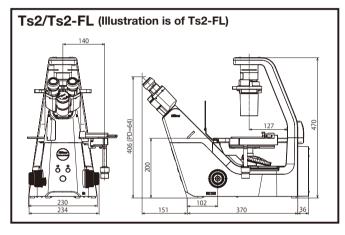
Note

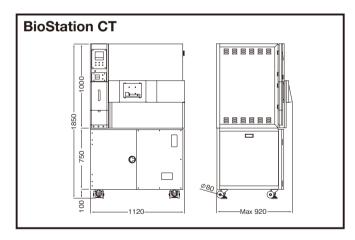
The lineup is constantly updated. For the latest information, please contact your local Nikon representative. The excitation filters or barrier filters in each filter cube are interchangeable. For custom setup, blank cubes without filters are also available. Please consult with your local Nikon distributor for a complete list of filters locally available or inquire about special custom filter combinations.

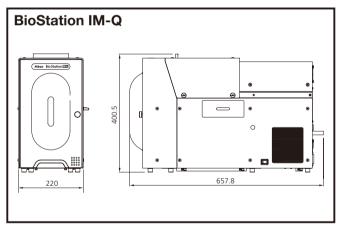
Dimensional Diagrams

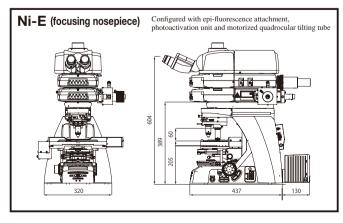


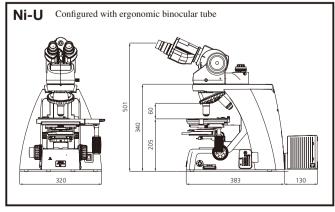


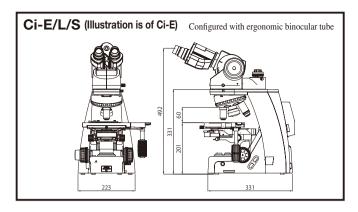


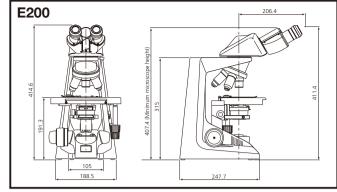


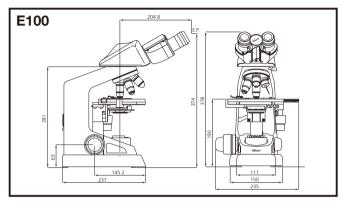


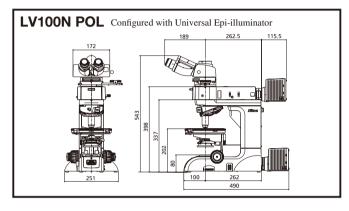


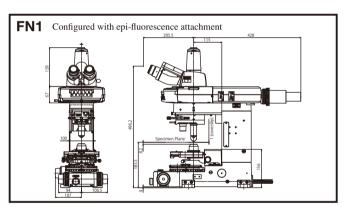


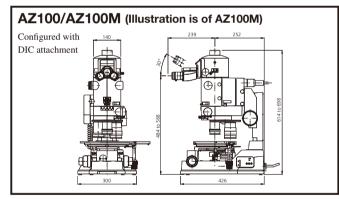


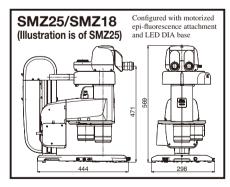


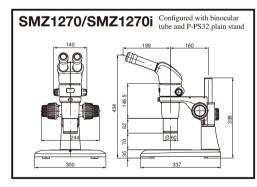


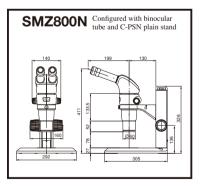


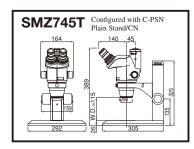


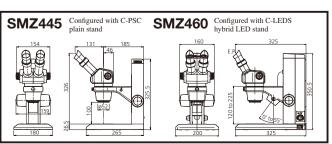












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NIKON CORPORATION

Shinagawa Intercity Tower C, 2-15-3, Konan, Minato-ku, Tokyo 108-6290, Japan phone: +81-3-6433-3705 fax: +81-3-6433-3785 http://www.nikon.com/products/microscope-solutions/

NIKON INSTRUMENTS INC.

1300 Walt Whitman Road, Melville, N.Y. 11747-3064, U.S.A. phone: +1-631-547-8500; +1-800-52-NIKON (within the U.S.A. only) fax: +1-631-547-0306

http://www.nikoninstruments.com/

NIKON INSTRUMENTS EUROPE B.V.

Tripolis 100, Burgerweeshuispad 101, 1076 ER Amsterdam, The Netherlands phone: +31-20-7099-000 fax: +31-20-7099-298

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NIKON INSTRUMENTS (SHANGHAI) CO., LTD.

CHINA phone: +86-21-6841-2050 fax: +86-21-6841-2060 (Beijing branch) phone: +86-10-5831-2028 fax: +86-10-5831-2026 (Guangzhou branch) phone: +86-20-3882-0550 fax: +86-20-3882-0580

NIKON CANADA INC.

CANADA phone: +1-905-602-9676 fax: +1-905-602-9953

NIKON FRANCE S.A.S.

FRANCE phone: +33-1-4516-45-16 fax: +33-1-4516-45-55

NIKON GMBH

GERMANY phone: +49-211-941-42-20 fax: +49-211-941-43-22

NIKON INSTRUMENTS S.p.A.

ITALY phone: +39-55-300-96-01 fax: +39-55-30-09-93

NIKON GMBH SWITZERLAND

SWITZERLAND phone: +41-43-277-28-67 fax: +41-43-277-28-61

NIKON UK LTD.

UNITED KINGDOM phone: +44-208-247-1717 fax: +44-208-541-4584

NIKON CEE GMBH

AUSTRIA phone: +43-1-972-6111 fax: +43-1-972-611-140

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NIKON SINGAPORE PTE LTD

SINGAPORE phone: +65-6559-3651 fax: +65-6559-3668

NIKON INSTRUMENTS KOREA CO., LTD.

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